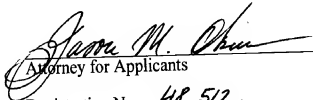


REMARKS

This Preliminary Amendment is to correct typographical errors in the citation of a document in the "BACKGROUND OF THE INVENTION" section of the specification. Clearly, no new matter has been added. Consideration and early issuance of the present application is respectfully requested.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants
Registration No. 48,512

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

NY_MAIN 206362 v 1

APPENDIX

Application No. 09/895,464
Attorney Docket No. 35.C15518

IN THE SPECIFICATION:

The paragraph beginning at page 4, line 13 and ending at page 4, line 17 has been amended as follows:

Another report by Masuda intends to dispose pores in rows by anodically oxidizing Al film in a film surface direction, the Al film being sandwiched between insulators (refer to "Appl. Phys. Lett." 63, p. 3155 (1993) [p3155 (1993)]).